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| Substitute for form 1449A/PTO<br><br><b>INFORMATION DISCLOSURE<br/>STATEMENT BY APPLICANT</b><br><br><i>(Use as many sheets as necessary)</i> | Application Number     |    | Filed Herewith    |                        |         |
|   | Filing Date            |    | February 24, 2004 |                        |         |
|   | First Named Inventor:  |    | Chee-Wee Liu      |                        |         |
|   | Examiner name: unknown |    | GROUP: unknown    |                        |         |
| Sheet   | 1                      | of | 1                 | Attorney Docket Number | D&F-040 |

## U.S. PATENT DOCUMENTS

| Examiner Initials* | Cited No. <sup>1</sup> | Document Number<br>Number - Kind Code <sup>2</sup> (if known) | Publication Date<br>MM-DD-YYYY | Name of Patentee or<br>Applicant of Cited Document | Pages, Columns, Lines<br>Where Relevant Passages or<br>Figures Appear |
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## FOREIGN PATENT DOCUMENTS

| Examiner Initials* | Cite No. <sup>1</sup> | Foreign Patent Document<br>Cntry Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known) | Publication Date<br>MM-DD-YYYY | Name of Patentee or<br>Applicant of Cited Document | Pages, Columns, Lines<br>Where Relevant<br>Passages or Figures<br>Appear | T <sup>6</sup> |
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## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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| EO                  | G. Kastner and Gosele, "Principles Of Strain Relaxation In Heteroepitaxial Films Growing On Compliant Substrate", J. Appl. Phys., Vol. 88, pp. 4048-4055, 2000.               |
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| EO                  | F. M. Bufler, "Hole Transport In Orthorhombically Strained Si", Journal Of Computational Electronics, Vol. 1, pp. 175-177, 2002.  |
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| EXAMINER SIGNATURE: | DATE CONSIDERED: 12/10/04   |

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